Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 U.S.A.

Re: New Utility Patent Application

Type:

U.S. National Stage application under 35 USC 371

Atty. Docket No: PA214WP002 First Inventor: Fumi NABESHIMA

Assignee:

Komatsu Electronic Metals Co., Ltd.

Title:

SEMICONDUCTOR WAFER INSPECTION DEVICE AND

**METHOD** 

Sir:

With regard to the captioned new utility patent application filed concurrently herewith, please note that this submission contains the following material, in order:

- (1) Utility Patent Application Transmittal Form;
- (2) Fee Transmittal Form and Appropriate Fee;
- (3) Application Data Sheet;
- (4) Specification consisting of 39 pages;
- (5) Drawings consisting of 6 pages;
- (6) Signed Combined Declaration and Power of Attorney (4 pages);
- (7) Assignment of the application (1 page);
- (8) International Search Report; and
- (9) Certified Copy of Priority Document.

Respectfully submitted,

bseph P. Farrar

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JF/so